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OGOSH25USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3/A

In re the Application of:)	
)	Examiner:
Yuichiro Shindo et al.)	
)	Group Art Unit:
Application No.:)	
)	
Corresponding International Filing No.:)	
PCT/JP2003/010251)	
)	
Filed: Herewith)	
)	
For: HIGH PURITY COPPER)	
SULFATE AND METHOD)	
FOR PRODUCTION THEREOF)	

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Commissioner for Patents
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FIRST PRELIMINARY AMENDMENT

Sir:

Before calculating the filing fee, please amend the above-identified patent application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page two of this paper.

Remarks begin on page three of this paper.